## Notice of References Cited Application/Control No. 10/670,269 Examiner Jean E. Lesperance Applicant(s)/Patent Under Reexamination HSIEH, YOU-JUN Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,686,908	02-2004	Kobayashi, Hideo	345/173
*	В	US-2002/0109675	08-2002	Kuan, Yen Liang	345/168
*	O	US-5,717,428	02-1998	Barrus et al.	345/168
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	7	US-			
	к	US-			
	L	US-	4		
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р			***		
	a					
	R					
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	v	
	w	
	×	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.